

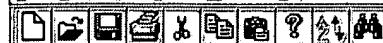


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• L2: (1590) electric with double adj layer adj capacitor.ti.
• L3: (0) 2 and(coefficient near elongation)
• L4: (0) 2 and(coefficient adj elongation)
• L5: (20) 2 and(coefficient)
• L6: (0) 5 and(curvature)
• L7: (5) 2 and(curvature)
• L8: (3) 7 and(thickness)
• L9: (15) 361/502 and(curvature)
• L10: (11) 9 and(thickness)
• L11: (3) 9 and(thickness near electrode)
• L12: (6) double with layer with capacitor.ti. and(curvature)
• L13: (0) 361/\$.ccls. and(curvature with thickness near electrode)
• L14: (1224) 361/\$.ccls. and(curvature)
• L15: (25) 14 and(thickness near electrode)
• L16: (29) 361/503 and(coefficient)
• L17: (13) 16 and(electrode near thickness)
• L18: (3) 17 and(curvature)
• L19: (447) 361/509
• L20: (5) 361/512 and(curvature)
• L21: (0) 361/512 and(coefficinet with electrode)
• L22: (2) 361/512 and(coefficient with electrode)
• L23: (1) 361/508 and(coefficient with electrode)
• L24: (1) 361/504 and(coefficient with electrode)
• L25: (0) 361/516 and(coefficient with electrode)
• L27: (0) 361/520 and(coefficient with electrode)
• L26: (2) 361/517 and(coefficient with electrode)
• L28: (1) 361/511 and(coefficient with electrode)
• L29: (1) 361/513 and(coefficient with electrode)
• L30: (15) Iwaida.in. and(capacitor)
• L31: (12) 30 and(electrode)
• L32: (0) 31 and(curvature)
• L33: (326) Manabu.in.. and(curvature)

U	S	Document ID	Issue Da	Page	Title	Current	OR	Current	XR	Retrieval	Inventor	S	C	E
1	2	3	4	5	6	7	8	9	10	11	12	13	14	15

[Search](#) [Document](#) [HTML](#)



default.wsp:1

	<input type="checkbox"/> U	Document ID	Issue Da	Page	Title	Current OR	Current XR	Retrieval	Inventor	S	C	P
1	<input type="checkbox"/>	US 20030007317	20030109	23	Non-symmetric capacitor with aluminum	361/503		361/503	Hudis, Martin	<input checked="" type="checkbox"/>	<input type="checkbox"/>	
2	<input checked="" type="checkbox"/>	US 6689424	20040210	9	Solid lubricant coatings produced by t	427/456	427/455		Wang, You et al.	<input type="checkbox"/>	<input type="checkbox"/>	
3	<input checked="" type="checkbox"/>	US 6687116	20040203	23	Non-symmetric capacitor with conduct	361/502			Hudis, Martin	<input type="checkbox"/>	<input type="checkbox"/>	
4	<input checked="" type="checkbox"/>	US 6686193	20040203	78	High throughput method and system for screeni	435/285.2	435/287.1;		Maher, Michael P.	<input type="checkbox"/>	<input type="checkbox"/>	
		B2			coatings produced by t		435/288.4;		et al.			
5	<input checked="" type="checkbox"/>	US 6663760	20031216	25	Method of fabricating two-terminal nonlinear	205/122	205/124;		Inoue, Takashi et	<input type="checkbox"/>	<input type="checkbox"/>	
		B2					205/234;		al.			
6	<input checked="" type="checkbox"/>	US 6657850	20031202	17	Electric double layer capacitor and method o	361/502	361/503	361/503	Nakazawa, Yutaka	<input type="checkbox"/>	<input type="checkbox"/>	
		B2			capacitor and method o				et al.			
7	<input checked="" type="checkbox"/>	US 6621686	20030916	23	Implantable medical device having flat ele	361/508	361/503	361/503	Jenn-Feng, Yan et	<input type="checkbox"/>	<input type="checkbox"/>	
		B1							al.			
8	<input type="checkbox"/>	US 6560089	20030506	54	Implantable medical device having flat ele	361/509	29/25.01;	361/503	Miltich, Thomas	<input checked="" type="checkbox"/>	<input type="checkbox"/>	
		B2					29/25.03;		P. et al.			
9	<input checked="" type="checkbox"/>	US 6529366	20030304	8	Solid electrolytic capacitor and method o	361/523	29/25.01;	361/503	Nakamura,	<input type="checkbox"/>	<input type="checkbox"/>	
		B2			capacitor and method o		29/25.03;		Takahiro			
10	<input checked="" type="checkbox"/>	US 6493212	20021210	54	Implantable medical device having flat ele	361/521	361/509;		Clarke, Michael	<input type="checkbox"/>	<input type="checkbox"/>	
		B1					361/519;		E. et al.			
11	<input type="checkbox"/>	US 6477037	20021105	50	Implantable medical device having flat ele	361/520	361/509;		Nielsen,	<input checked="" type="checkbox"/>	<input type="checkbox"/>	
		B1					607/5		Christian S. et a			
12	<input checked="" type="checkbox"/>	US 6466429	20021015	8	Electric double layer capacitor	361/502	361/503	361/503	Volkovich, Yuri	<input type="checkbox"/>	<input type="checkbox"/>	
		B1							M. et al.			
13	<input checked="" type="checkbox"/>	US 6459566	20021001	59	Implantable medical device having flat ele	361/517	361/503;	361/503	Casby, Kurt J. et	<input type="checkbox"/>	<input type="checkbox"/>	
		B1					361/508;		al.			
14	<input checked="" type="checkbox"/>	US 6449139	20020910	31	Multi-electrode double layer capacitor having	361/502	29/25.03;	361/503	Farahmandi, C.	<input type="checkbox"/>	<input type="checkbox"/>	
		B1					361/503;		Joseph et al.			
15	<input checked="" type="checkbox"/>	US 6442016	20020827	8	Solid-state electrolytic capacitor	361/523	361/525		Fukuyama, Sachiko	<input type="checkbox"/>	<input type="checkbox"/>	
		B2							et al.			
16	<input checked="" type="checkbox"/>	US 6417062	20020709	7	Method of forming ruthenium oxide films	438/384	257/E21.00		Foust, Donald	<input type="checkbox"/>	<input type="checkbox"/>	
		B1					6.		Franklin et al.			
17	<input checked="" type="checkbox"/>	US 6414837	20020702	10	Electrochemical capacitor	361/504	29/25.03;	361/503	Sato, Kenji et	<input type="checkbox"/>	<input type="checkbox"/>	
		B1					361/503;		al.			
18	<input checked="" type="checkbox"/>	US 6409776	20020625	22	Implantable medical device having flat ele	29/25.03	361/508;		Yan, Jenn-Feng et	<input type="checkbox"/>	<input type="checkbox"/>	
		B1					361/509;		al.			
19	<input type="checkbox"/>	US 6402793	20020611	56	Implantable medical device having flat ele	29/25.03	361/509;		Miltich, Thomas	<input checked="" type="checkbox"/>	<input type="checkbox"/>	
		B1					361/520;		P. et al.			



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L8: (3) 7 and(thickness)

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12	<input checked="" type="checkbox"/>	US 6466429	20021015	8	Electric double layer capacitor	361/502	361/503	361/503	Wolkovich, Yuri M. et al.	<input type="checkbox"/>	<input type="checkbox"/>	
		B1										
13	<input checked="" type="checkbox"/>	US 6459566	20021001	59	Implantable medical device having flat electrode	361/517	361/503; 361/508;	361/503	Casby, Kurt J. et al.	<input type="checkbox"/>	<input type="checkbox"/>	
		B1										
14	<input checked="" type="checkbox"/>	US 6449139	20020910	31	Multi-electrode double layer capacitor having	361/502	29/25.03; 361/503;	361/503	Farahmandi, C. Joseph et al.	<input type="checkbox"/>	<input type="checkbox"/>	
		B1										
15	<input checked="" type="checkbox"/>	US 6442016	20020827	8	Solid-state electrolytic capacitor	361/523	361/525		Fukuyama, Sachiko et al.	<input type="checkbox"/>	<input type="checkbox"/>	
		B2										
16	<input checked="" type="checkbox"/>	US 6417062	20020709	7	Method of forming iruthenium oxide films	438/384	257/E21.00		Foust, Donald Franklin et al.	<input type="checkbox"/>	<input type="checkbox"/>	
		B1										
17	<input checked="" type="checkbox"/>	US 6414837	20020702	10	Electrochemical capacitor	361/504	29/25.03; 361/503;	361/503	Sato, Kenji et al.	<input type="checkbox"/>	<input type="checkbox"/>	
		B1										
18	<input checked="" type="checkbox"/>	US 6409776	20020625	22	Implantable medical device having flat electrode	29/25.03	361/508; 361/509;		Yan, Jenn-Feng et al.	<input type="checkbox"/>	<input type="checkbox"/>	
		B1										
19	<input checked="" type="checkbox"/>	US 6402793	20020611	56	Implantable medical device having flat electrode	29/25.03	361/509; 361/520;		Miltich, Thomas R. et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	
		B1										
20	<input checked="" type="checkbox"/>	US 6246569	20010612	6	Electrolytic capacitor and method of manufacture	361/508	29/25.03; 361/516		Strange, Thomas E. et al.	<input type="checkbox"/>	<input type="checkbox"/>	
		B1										
21	<input checked="" type="checkbox"/>	US 6212063	20010403	62	Implantable medical device having flat electrode	361/517	361/502; 361/504;		Johnson, William L. et al.	<input type="checkbox"/>	<input type="checkbox"/>	
		B1										
22	<input checked="" type="checkbox"/>	US 6208502	20010327	19	Non-symmetric capacitor	361/503	361/502	361/503	Hudis, Martin et al.	<input type="checkbox"/>	<input type="checkbox"/>	
		B1										
23	<input checked="" type="checkbox"/>	US 6184160	20010206	57	Method of making an hermetically sealed implant	438/800	29/25.03; 427/2.24		Yan, Jenn-Feng et al.	<input type="checkbox"/>	<input type="checkbox"/>	
		B1										
24	<input checked="" type="checkbox"/>	US 6157531	20001205	60	Implantable medical device having flat electrode	361/519	361/509; 361/516;		Breyen, Mark D. et al.	<input type="checkbox"/>	<input type="checkbox"/>	
		A										
25	<input checked="" type="checkbox"/>	US 6118652	20000912	58	Implantable medical device having flat electrode	361/517	361/503; 361/508;	361/503	Casby, Kurt J. et al.	<input type="checkbox"/>	<input type="checkbox"/>	
		A										
26	<input checked="" type="checkbox"/>	US 6099600	20000808	58	Method of making a vacuum-treated liquid	29/25.03			Yan, Jenn-Feng et al.	<input type="checkbox"/>	<input type="checkbox"/>	
		A										
27	<input checked="" type="checkbox"/>	US 6006133	19991221	64	Implantable medical device having flat electrode	607/5	29/25.03; 361/503	361/503	Lessar, Joseph F. et al.	<input type="checkbox"/>	<input type="checkbox"/>	
		A										
28	<input checked="" type="checkbox"/>	US 5995361	19991130	29	Liquid crystalline polymer capacitors	361/511	264/289.3; 361/524;		Jayaraj, Kumaraswamy et al.	<input type="checkbox"/>	<input type="checkbox"/>	
		A										
29	<input checked="" type="checkbox"/>	US 5827602	19981027	14	Hydrophobic ionic liquids	429/328	204/242; 252/62.2;	361/503	Koch, Victor R. et al.	<input type="checkbox"/>	<input type="checkbox"/>	
		A										

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